



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	Potyrailo et al.	Docket:	131973 (1306-29)
Serial No.:	10/723,536	Examiner:	Not Yet Known
Filed:	November 24, 2003	Art Unit:	Not Yet Known
For:	METHODS FOR DEPOSITION OF SENSOR REGIONS ONTO OPTICAL STORAGE MEDIA SUBSTRATES AND RESULTING DEVICES	Dated:	February 5, 2004

Commissioner for Patents
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CHANGE OF CORRESPONDENCE ADDRESS IN APPLICATION

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Respectfully submitted,

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Assistant Commissioner for Patents, Washington, D.C. 20231 on February 5, 2004.

Dated: February 5, 2004

Jennifer Vitale